Notice of Allowability	Application No.		Applicant(s)	
	09/936,323	09/936,323 MINAMI ET AL.		
	Examiner		Art Unit	
	Amanda C W	/alke	1752	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.				
 This communication is responsive to the application filed 9/12/2001. The allowed claim(s) is/are 1-106. The drawings filed on are accepted by the Examiner. 				
Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) ☑ All b) ☐ Some* c) ☐ None of the:				
1. Certified copies of the priority documents have been received.				
2. Certified copies of the priority documents have been received in Application No				
 Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)). 				
* Certified copies not received:				
5. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).				
(a) The translation of the foreign language provisional application has been received.				
6. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.				
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.				
7. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.				
 8. CORRECTED DRAWINGS must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2 is to Paper No (b) including changes required by the proposed drawing correction filed, which has been approved by the Examiner. 				
(c) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No				
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet.				
9. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.				
Attachment(s)		_		
1 Notice of References Cited (PTO-892) 3 Notice of Draftperson's Patent Drawing Review (PTO-948) 5 Information Disclosure Statements (PTO-1449), Paper No. Examiner's Comment Regarding Requirement for Deposit of Biological Material	<u>4210</u> 1201	4☐ Interview Summa 6☐ Examiner's Ame	al Patent Application (ary (PTO-413), Paper ndment/Comment ement of Reasons for	No

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Allowable Subject Matter

1. Claims 1-106 are allowed.

2. The following is an examiner's statement of reasons for allowance: In the application filed 9/12/2001, applicant claimed a method for producing a pattern film-coated article comprising coating a photosensitive resin which comprises an organometallic or organosilicon compound which is an allyl group-containing metal or silicon alkoxide and a hydrolyzable metal or silicon alkoxide onto a substrate. The examiner performed a search of the prior art of record, and found three relevant references, however, none anticipate or obviate the instant claims. The examiner also considered the references listed on the information disclosure statements and the International search reports, but none of the references cited were applicable. Therefore, the instant claims 1-106 are now allowable over the prior art of record.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

 The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Hanabata et al (6,183,935 and 6,534,235) are cited for their teachings of a photosensitive resin comprising a condensable (hydrolytic polymerizable) organic metal compound which may be trimethoxysilane, triethoxysilane, allyltriethoxysilane, or allyltrimethoxysilane, however, there is no teaching or suggestion to choose two compounds from the list provided which would

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meet the present claim limitations (column 6, line 26 to column 8, line 24; citation from the '935 reference although both have this teaching).

Nakamura (6,632,585) is cited for its teaching of a photosensitive resin comprising a silane compound and a metal compound. The reference fails to teach or suggest the use of an allyl group-containing metal or silicon alkoxide in combination with a hydrolyzable metal or silicon alkoxide.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Amanda C Walke whose telephone number is 703-305-0407. The examiner can normally be reached on M-R 5:30-4.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Mark Huff can be reached on 703-308-2426. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0661.

Amanda C Walke

Examiner Art Unit 1752

ACW November 16,2003

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